

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hayashi et al.

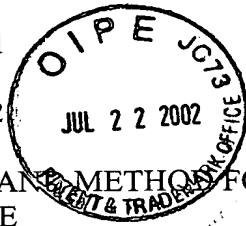
Attorney Docket No.: SIP1P049

Application No.: 10/088,281

Examiner: Unassigned

Filing Date: March 13, 2002

Group: Unassigned

Title: OPTICAL FILTER AND METHOD FOR
MANUFACTURING SAME

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on July 17, 2002.

Signed:

Lara M. Nelson

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§1.56 AND 1.97(c)

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. Also enclosed is a copy of an International Search Report dated December 12, 2000 that was issued in the corresponding Japanese Application.

1. Japanese Publication No. 06-118228 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.
2. Japanese Publication No. 09-211220 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.
3. Japanese Publication No. 10/242441 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.
4. Japanese Publication No. 10-282335 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.
5. Japanese Publication No. 11-315215 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.
6. PCT No. WO 99/10354 - A brief summary of the Japanese application is provided in the English Language Abstract of the invention included herewith.

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This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

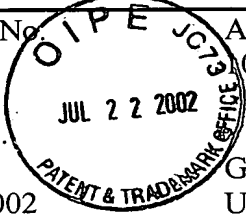
This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. SIP1P049).

Respectfully submitted,
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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. SIP1P049 Applicant: Hayashi et al. Filing Date March 13, 2002	Application No.: 0/088,281 Group Unassigned
		

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	5,567,778	10/22/96	Sakagami et al.			
	B						
	C						
	D						
	E						
	F						
	G						
	H						
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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	J	06-118228	04/28/94	Japan				
	K	09-211220	08/15/97	Japan				
	L	10/242441	09/11/98	Japan				
	M	10-282335	10/23/98	Japan				
	N	0 586 135 A2	03/09/94	EPO				
	O	11-315215	11/16/99	Japan				
	P	WO 99/10354	03/04/99	Japan				
	Q	EP 1 008 599 A1	06/14/00	EPO				

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.